

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:	:	Group Art Unit:
Crawford, et. al.	:	Intellectual Property Law Department
Serial No.:	:	International Business
Filed: <i>Herewith 11/21/03</i>	:	Machines Corporation
Title: System and Method for Process	:	Software Group IP Law -- T81/503
Driven Quality Measures	:	3039 Cornwallis Road
	:	Research Triangle Park, NC 27709

**INFORMATION DISCLOSURE STATEMENT**

The Assistant Commissioner of Patents  
Washington, D.C. 20231

Sir:

Applicants submit herewith patents, publications or other information of which they are aware, which they believe may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.


While this Information Disclosure Statement may be "material" pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication or other information referred to herein is "prior art" for this invention unless specifically designated as such.

In accordance with 37 CFR § 1.97(g) the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR § 1.56 (a) exists.

The attached form, PTO-1449, provides a listing of patents, publications, or other information as required by 37 CFR § 1.98 (a)(1).

A copy of each of the items on PTO-1449 is supplied herewith.

Respectfully submitted,

By   
Joseph T. Van Leeuwen  
Attorney for Applicant  
Registration No. 44,383  
Telephone: (512) 301-6738  
Facsimile: (512) 301-6742

In Place of FORM PTO-1449 (Modified)

Serial No. \_\_\_\_\_

**LIST OF PATENTS AND PUBLICATIONS FOR  
APPLICANT'S INFORMATION DISCLOSURE  
STATEMENT**

Applicant: Crawford, et. al.

Filing Date: \_\_\_\_\_

Group: \_\_\_\_\_

Atty. Docket No. RSW920030203US1

**U. S. PATENT DOCUMENTS**

Examiner <u>Initial</u>	<u>Document Number</u>	<u>Date</u>	<u>Name</u>	<u>Class</u>	<u>Subclass</u>	<u>Filing Date if Appropriate</u>
_____	AA 2003/0018511	Jan 23, 2003	Bicknell et al.	705	9	
_____	AB 6,535,775	Mar 18, 2003	Bagepalli et al.	700	109	
_____	AC 2003/0135399	Jul 17, 2003	Ahamparam et al.	705	7	
_____	AD 2002/0165765	Nov 7, 2002	Sommerfeld et al.	705	14	
_____	AE 5,278,751	Jan 11, 1994	Adiano et al.	364	402	
_____	AF					
_____	AG					
_____	AH					
_____	AI					
_____	AJ					
_____	AK					
_____	AL					

**FOREIGN PATENT DOCUMENTS**

Examiner <u>Initial</u>	<u>Document Number</u>	<u>Date</u>	<u>Country</u>	<u>Class</u>	<u>Subclass</u>	<u>Translation Yes No</u>
_____	AM 11-288427	Oct 19, 1999	Japan	G06F	17/50	No
_____	AN					
_____	AO					
_____	AP					

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)**

Examiner <u>Initial</u>	AQ	Vouk, "Software Reliability Engineering," <u>2000 Annual Reliability and Maintainability Symposium, 2000.</u>
_____	AR	
_____	AS	
_____	AT	

Examiner: \_\_\_\_\_

Date Considered: \_\_\_\_\_

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.